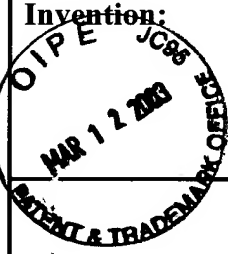
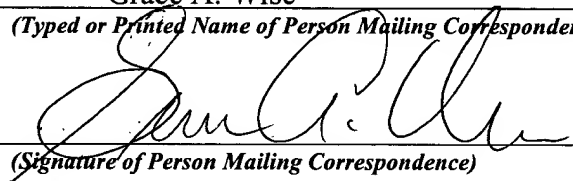


<b>CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)</b> Applicant(s): Masahiro Ishida, et al.			<b>Docket No.</b> 02008.071001; AD-0243PCTUS
<b>Serial No.</b> 09/980,891	<b>Filing Date</b> December 3, 2001	<b>Examiner</b> T. Nguyen	<b>Group Art Unit</b> 2829
<b>Invention:</b>  <b>METHOD AND APPARATUS FOR DEFECT ANALYSIS OF SEMICONDUCTOR INTEGRATED CIRCUIT</b>			
I hereby certify that this <u>Preliminary Amendment along with required papers</u> (Identify type of correspondence) is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The Assistant Commissioner for Patents, Washington, D.C. 20231 on <u>March 7, 2003</u> . (Date)			
<div>Grace A. Wise (Typed or Printed Name of Person Mailing Correspondence)</div> <div> (Signature of Person Mailing Correspondence)</div>			
Note: Each paper must have its own certificate of mailing.			